

TRANSMITTAL LETTER

DOCKET NO. MICR155

SERIAL NO.

08/636,069

FILING DATE

Apr 22, 1996

EXAMINER

Whipple, Matthew

GROUP ART UNIT

1104

INVENTOR(S): Sandhu, Gurtej

INVENTION: **Method To Reduce Fixed Charge In CVD Ozon Deposited Films**

TO THE COMMISSIONER OF PATENTS AND TRADEMARKS:

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated as shown below.

RECEIVED

DEC 18 1997

1	*2*	*3*	*4*	*5*	*6*	*7*
	Claims Remaining After Amendment		Highest Number Previously Paid For	No. of Extra Claims Present	Rate	Additional Fee
TOTAL CLAIMS	* 30	MINUS	** 24	- 6 -	X \$22	\$ - 132.00 -
INDEP. CLAIMS	* 6	MINUS	*** 3	- 3 -	X \$82	\$ - 246.00 -
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$ -378.00 -

* If the entry in column 2 is less than the entry in column 4, write "0" in column 5.

** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.

*** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.

☐ No additional fee is required.☐ Charge \$ _____ to Deposit Account No.. A triplicate copy of this sheet is enclosed.☐ Please charge any additional fees (except for the issue fee) or credit overpayment to Deposit Account No.. A triplicate copy of this sheet is enclosed.☐ The undersigned petitions for any extensions of time for filing this document required under 34 CFR 1.136 and request that the \$ _____ fee be charged to Deposit Account No.. A triplicate copy of this sheet is enclosed.

12/08/1997 MPEP/LES 00000073 08636069

01 FC:103 hereby certify that this paper and the documents referred to as
 02 FC:103 enclosed therein are being deposited with the United States
 Postal Service as first class mail in an envelope addressed to:
 Commissioner of Patents and Trademarks, Washington, DC
 20231 on: November 25, 1997.

Margaret M. Dunbar
 (Signature of person mailing papers)

Margaret M. Dunbar

Margaret M. Dunbar
 Attorney for Applicant(s)
 Registration No. 37,818
 Ormiston Korfanta Dunbar & Holland, P.L.L.C.
 P.O. Box 1840
 Boise, Idaho 83701-1840
 voice: (208) 336-1234
 fax: (208) 336-8344



#5/a
mR
12/24/97

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Sandhu, Gurtej

Serial number:

08/636,069

Filed:

4/22/96

Group Art Unit:

1104

Examiner:

Matthew Whipple

Title:

**Method To Reduce Fixed Charge In
CVD Ozone Deposited Films**

RESPONSE TO OFFICE ACTION

Mailed: **08/18/97**

AMENDMENT A

COMMISSIONER OF PATENTS AND TRADEMARKS

Box Fee Amendment

Commissioner of Patents and Trademarks

Washington, DC 20231

Dear Sir:

In response to the Office Action mailed August 18, 1997, please enter the following amendments and remarks of record.

IN THE SPECIFICATION

On page 6, line 3, after "volume." please insert the sentence -- The term
substrate refers to one or more semiconductor layers or structures which
includes active or operable portions of semiconductor devices. --.

On page 6, line 6, after "reaction" please insert -- volume of gas, above
the --.

On page 8, line 3, after the word "turn" please delete the word "will".